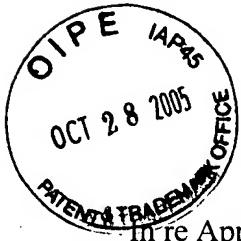


AF/DW

Docket No.: 061282-0035

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE

In re Application of

ITO, MITSUMI, et al.

Application No.: 10/634,988

Filed: August 06, 2003

: Customer Number: 20277
:
: Confirmation Number: 7469
:
: Group Art Unit: 2825
:
: Examiner: Stacy Whitmore
:

For: SEMICONDUCTOR DEVICE, METHOD OF GENERATING PATTERN FOR
SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR
DEVICE AND DEVICE OF GENERATING PATTERN USED FOR SEMICONDUCTOR
DEVICE

REQUEST FOR RECONSIDERATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 28, 2005, having a three-month shortened statutory period for response set to expire on October 28, 2005, reconsideration of the above-identified application is respectfully requested in view of the following remarks.